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| Notice of References Cited | Application/Control No. 09/857,310 | Applicant(s)/Patent Under Reexamination VAN VAALS, JOHANNES JACO | |
| | Examiner Tiffany A Fetzner | Art Unit 2859 | Page 1 of 1 |

U.S. PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Name | Classification |
|---|---|--|-----------------|-------------------|----------------|
| | A | US-6,026,316 | 02-2000 | Kucharczyk et al. | 600/420 |
| | B | US-6,061,587 | 05-2000 | Kucharczyk et al. | 600/411 |
| | C | US-6,298,259 B1 | 10-2001 | Kucharczyk et al. | 600/411 |
| | D | US-5,964,705 | 10-1999 | Truwit et al. | 600/423 |
| | E | US-6,272,370 B1 | 08-2001 | Gillies et al. | 600/411 |
| | F | US- | | | |
| | G | US- | | | |
| | H | US- | | | |
| | I | US- | | | |
| | J | US- | | | |
| | K | US- | | | |
| | L | US- | | | |
| | M | US- | | | |

FOREIGN PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Country | Name | Classification |
|---|---|--|-----------------|---------|------|----------------|
| | N | | | | | |
| | O | | | | | |
| | P | | | | | |
| | Q | | | | | |
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| | S | | | | | |
| | T | | | | | |

NON-PATENT DOCUMENTS

| * | | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) |
|---|---|---|
| | U | |
| | V | |
| | W | |
| | X | |

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